Electronic Patent Application Fee Transmittal							
Application Number:	10549294						
Filing Date:	16-Sep-2005						
Title of Invention:	Material for purification of semiconductor polishing slurry, module for purification of semiconductor polishing slurry and process for producing semiconductor polishing slurry						
First Named Inventor/Applicant Name:	Mitsugu Abe						
Filer:	Marvin Jay Spivak/Genet Tsige						
Attorney Docket Number:	278426US0PCT						
Filed as Large Entity							
U.S. National Stage under 35 USC 371 Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							
Extension - 1 month with \$0 paid		1251	1	120	120		

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
	Total in USD (\$)			120